

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Number : 10/584,301 Confirmation No.: 9824  
Applicant : Henrik JENSEN, et al.  
Filed : September 27, 2005  
Title : METHOD AND APPARATUS FOR PRODUCTION OF A  
COMPOUND HAVING SUBMICRON PARTICLE SIZE, AND A  
COMPOUND PRODUCED BY THE METHOD  
TC/Art Unit : 1793  
Examiner: : Unassigned  
  
Docket No. : 55320.000402  
Customer No. : **21967**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.97 and 1.98, and in compliance with the duty of disclosure set forth in 37 C.F.R. § 1.56, applicants submit attached Form PTO-SB/08A (modified) for consideration and request the references cited therein be made of record by the U.S. Patent and Trademark Office in the above-captioned application.

In accordance with 37 C.F.R. § 1.98(a)(2)(ii), copies of cited U.S. patents and/or U.S. patent application publications for national stage applications under 35 U.S.C. 371, are not being provided.

In considering the cited references, it may be noted by the Examiner that certain of the references may contain markings, underlinings, and/or other notations. These markings, underlinings, and/or other notations are not to be construed as drawing the Examiner's attention either to selected parts or away from other parts of the cited references. Any such markings were either present on the copies of the cited references obtained by the associated individuals, or were made thereon during the study of the references by the associated individuals.

The attached documents were cited by the Japanese Patent Office ("JPO") in the Official Action ("Action") dated February 10, 2009 of the corresponding patent application in

Japan No. 2004-514594 and relevance as asserted by the JPO Examiner is indicated on the enclosed Action.

Applicants respectfully point out that the submission of the listed references in this Information Disclosure Statement is not an admission that they are prior art or that they are material to patentability of any claims of the application. Also, the submission of this Information Disclosure Statement is not an indication that a search has been made by Applicants.

This Information Disclosure Statement is being submitted prior to issuance of a first Office Action, therefore, it is respectfully submitted that no fee is required for consideration of this information. However, in the event any fee is deemed necessary, the Commissioner is authorized to charge the undersigned's Deposit Account No. 50-0206.

Consideration of the foregoing plus the prompt return of a copy of the enclosed Form SB/08A with the Examiner's initials in the left column in accordance with MPEP 609 are respectfully requested.

Respectfully submitted,

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Dated: May 11, 2009

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